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| Notice of References Cited | | Application/Control No. 10/823,836 | Applicant(s)/Patent Under Reexamination RAVI, KRAMADHATI V. | |
| | | Examiner Patricia A. George | Art Unit 1765 | Page 1 of 2 |

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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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